

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of)
Tadahiro OHMI et al.) Group:
Serial No.:)
Filed: July 13, 2001) Examiner:
Title: METAL MATERIAL HAVING FORMED THEREON)
CHROMIUM OXIDE PASSIVE FILM AND METHOD))
FOR PRODUCING THE SAME, AND PARTS)
CONTACTING WITH FLUID AND SYSTEM FOR)
SUPPLYING FLUID AND EXHAUSTING GAS)

*WMA
2/18/02*

PRELIMINARY AMENDMENT

Hon. Commissioner of Patents and Trademarks
Washington, D.C. 20231

Sir:

Applicant hereby submits the following Amendment.

IN THE CLAIMS

1. (Amended) Metallic material provided with a chromium-oxide passivation film comprising a passivation film consisting of chromium oxide obtained by oxidizing a chromium coat on the metallic material of which surface roughness (Ra) is not more than [1.5im] 1.5μm.

2. (Amended) The metallic material provided with the chromium-oxide passivation film according to claim 1, said film having pin holes wherein pin holes of said chromium-oxide passivation film are filled.

3. (Amended) A method for manufacturing metallic material on which a chromium-oxide passivation film is formed, comprising the step of: